



PTO/SB/08A (08-03)

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Substitute for form 1449/PTO		<b>Complete if Known</b>			
		Application Number	10/713,475		
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Use as many sheets as necessary)		Filing Date	November 14, 2003		
		First Named Inventor	David H. Stark		
		Art Unit	To Be Assigned		
		Examiner Name	To Be Assigned		
Sheet	1	of	3	Attorney Docket Number	STRK-26,032

U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
HVN		US- 3,698,878	10/17/72	Hale et al.	
	02	US- 5,118,924	06/02/92	Mehra et al.	
	03	US- 5,302,414	04/12/94	Alkhimov et al.	
	04	US- 5,423,119	06/13/95	Yang	
	05	US- 6,139,913	10/31/00	Van Steenkiste et al	
	06	US- 6,191,359	02/20/01	Sengupta et al.	
	07	US- 6,627,814	09/30/03	Stark	
	08	US- 6,537,121	03/25/03	Baret	
	09	US- 6,548,895	04/15/03	Benavides et al.	
	10	US- 4,355,323	10/19/82	Hendrikus Kock	
	11	US- 5,945,721	08/31/99	Nobuyoshi Tatoh	
	12	US- 5,949,655	09/07/99	Thomas Glenn	
HVN	13	US- 6,020,628	02/01/00	Brian Mravic et al.	
	14	US-			
	15	US-			
	16	US-			
	17	US-			
	18	US-			
	19	US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> ~Number <sup>4</sup> ~Kind Code <sup>5</sup> (if known)				

Examiner Signature	HVN ✓ NAL	Date Considered	12-08-04
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		First Named Inventor	David H. Stark
		Art Unit	To Be Assigned
		Examiner Name	To Be Assigned
Sheet 2	of 3	Attorney Docket Number	STRK-26032

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
HVN	200	DORON TEOMIM, AVNER BADIHI, GIL ZILBER; "An innovative approach to wafer-level MEMS packaging"; Solid State Technology (Magazine); January 2002; Penwell (Publ.); Nashua, NH USA.	
HVN	201	Carpenter Specialty Alloys: Controlled-Expansion Alloys (Catalog/Brochure); December 1999; Pages 1-24 (esp. 5-8); Carpenter Technology Corporation (Publ.); Wyomissing, PA USA.	
HVN	202	JPL Technology Reporting Office; "Hermetic Wafer Bonding By Use of Microwave Heating"; NASA Tech Brief, Vol. 25, No. 5, from JPL New Technology Report NPO-20608 (NASA Contract No. NAS-7-918); May 1, 2001; Jet Propulsion Laboratory, California Institute of Technology (Publ.); Pasadena, CA, USA; including therein:	
HVN		NTR Inventors Report by HENRY W JACKSON, JOHN D MAI, MARTIN B BARMATZ, NASSER K BUDRAA, WILLIAM T PIKE; NASA Case No. 0205 20608; March 1997(?) (Best Available Copy); including therein: (same authors) "Low Pressure and Low Temperature Hermetic Wafer Bonding Using Microwave Heating"; Jet Propulsion Laboratory, California Institute of Technology, Pasadena, CA, USA (Best Available Copy)	
HVN	203	GEORGE S. BRADEY, ET AL., Materials Handbook, 12th Edition; 1986; pp 28-29; McGraw-Hill Book Company; New York.	
HVN	204	R.C. DYKHUIZEN ET AL.; Gas Dynamic Principles of Cold Spray; Journal of Thermal Spray Technology; Vol. 7(2); pp 205-212; June, 1998.	
HVN	205	KAZAKOV, N.F. (ed.); Diffusion Bonding of Materials; 1981; pp 4-9, 248-257; Pergamon Press; U. S. A.	
HVN	206	NICHOLS, M.G. & LEE, R. J.; Joining Dissimilar Materials, Metals and Materials, The Journal of the Institute of Metals, Vol. 5, No. 6, June 1989; UK.	
HVN	207	CERJAK, H. (ed.); Mathematical Modelling of Weld Phenomena 5; Diffusion Bonding of Glass to Metal in an Electrostatic Field; M. Morsy et al.; pp 945-959; London IOM Communications, 2001.	
HVN	208	OSTYN, K. & VINCKIER, A.; Joining of Different Materials Through Interfaces; Interfaces in Materials, Proceedings of the Colloquium; pp. 153-173; Brussels, 12/1988.	

Examiner Signature	HVN ✓ NCR	Date Considered	12-08-04
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HVN	209	ARATA ET AL. Pressure and Field Assisted Bonding of Glass to Aluminum; Transactions of JWRI is published by Welding Research Institute of Osaka University; Vol. 13; No. 1; 1984; pp 35-40.	
HVN	210	SADPYSKY ET AL.; Precision Welding of Glass to Kovar Without Melting; Svarochnoe Proizvodstvo; February 1973; pp 22; (In Russian, English translation provided).	✓
HVN	211	KAZAKOV ET AL.; Equipment for Diffusion Welding of Rectangular Glass Plates to Kovar; Svarochnoe Proizvodstvo; June 1977; p 50; (In Russian, English translation provided).	✓
HVN	212	PCT; International Search Report of PCT/US03/07553 (related application); International Publication No. WO 03/083938 A1; 16 June 2003; 2 pg.	

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